PROCEEDINGS OF SPIE

High Power Lasers and Applications

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19–23 April 2021 Online Only, Czech Republic

Sponsored by SPIE

Cooperating Organisations ELI Beamlines (Czech Republic) Laserlab Europe European Optical Society HiLASE Centre (Czech Republic)

Published by SPIF

Volume 11777

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Please use the following format to cite material from these proceedings: Author(s), "Title of Paper," in High Power Lasers and Applications, edited by Joachim Hein, Thomas J. Butcher, Pavel Bakule, Constantin L. Haefner, Georg Korn, Luis O. Silva, Proc. of SPIE 11777, Sevendigit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510643888

ISBN: 9781510643895 (electronic)

Published by

SPIF

P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) SPIE.org

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